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Practitioner's Docket No.: 782_181

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Tomohiko SHIBATA, Keiichi ASAI, and Mitsuhiro TANAKA

Ser. No.: 09/928,523

Group Art Unit: 1765

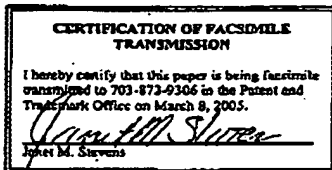
Filed: August 13, 2001

Examiner: Matthew J. Song

Confirmation No.: 8032

For: AN APPARATUS FOR FABRICATING A III-V NITRIDE FILM AND A METHOD FOR FABRICATING THE SAME

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Office Action mailed December 8, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.

Entered w/RCE
dd
4/4/05
kw